

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE

APPLICATION OF: DIMITRI LEDERER ET AL.

SERIAL NO.: 10/572,799

FILED: March 22, 2006

FOR: METHOD OF MANUFACTURING A  
MULTILAYER SEMICONDUCTOR  
STRUCTURE WITH REDUCED  
OHMIC LOSSES

CONFIRMATION NO. 4919

GROUP ART UNIT: 2891

EXAMINER: Julia Slutsker

ATTY. REFERENCE: LEDE3001/JJC/JDG



## PETITION FOR EXTENSION OF TIME

COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136 (a) for:

- One Month       Three Months  
 Two Months       Four Months  
 Five Months

- The fee set in 37 CFR 1.17 for the extension of time is **\$245.00**
- Fee enclosed. Please charge any additional fee required for this extension of time to **Deposit Account Number 02-0200**.
- Charge fee to **Deposit Account Number 02-0200**. A duplicate copy of this paper is enclosed.
- Applicant is a **small entity** entitled to pay reduced fees in this application.

Also enclosed is a:

- Amendment and Reply to Office Action of November 7, 2008

**23364**  
Customer Number  
Phone: (703) 683-0500

Respectfully submitted,

  
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RICHARD E. FICHTER  
Attorney for Applicant  
Registration Number: 26,382

DATE: April 7, 2009

04/09/2009 LLANDGRA 00000002 10572799

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